Customer No. 22,852 Attorney Docket No. 03180.0327

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re	Application of:)
Kazuy	/a FUKUHARA et al.))
Serial	No.: Not Yet Assigned) Group Art Unit:
	July 9, 2003) Examiner:)
For:	INSPECTION METHOD AND A PHOTOMASK)))
P.O. E	nissioner for Patents Box 1450 ndria, VA 22313-1450	
Sir:		

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO-1449. Copies of the listed documents are attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO-1449 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the above-referenced application.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine

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that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the office the relevant facts and law regarding the appropriate status of such documents. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: July 9, 2003

Richard V. Burgujian Reg. No. 31,744

Enclosures RVB/FPD/cgb

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INFORMATION DISCLOSURE CITATION

Atty. Docket No.	03180.0327	Serial No.	
Applicant	Kazuya FUKUHARA et al.		
Filing Date	July 9, 2003	Group:	

	U.S. PATENT DOCUMENTS					
Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
	6,130,747	10/10/2000	Nomura et al.	356	239.2	

	FOREIGN PATE	NT DOCUMENT	s		-
Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
Hiroshi Nomura, "Investigation of High-Precision Lithography Lens Aberration Measurement Based on Three-Beam Interference Theory: Sensitivity versus Coherent Factor and Variations with Dose and Focus, Optical Review, Vol. 7, No. 6 (July, 2000), p.p. 525-534			

Examiner		Date Considered	
*Examiner:	Initial if reference through citation it communication to	ence considered, whether or not citation is in conformance with MPEP 609; draw line on if not in conformance and not considered. Include copy of this form with next on to applicant.	
Form PTO 1449		Patent and Trademark Office - U.S. Department of Commerce	